IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant(s):

NA, Kee Yeol et al.

Application No.:

Filed:

June 5, 2001

Examiner:

For:

NON-VOLATILE MEMORY DEVICE AND FABRICATION METHOD

LETTER

Assistant Commissioner for Patents Box Patent Application Washington, D.C. 20231

June 5, 2001 0465-0747P

Sir:

Under the provisions of 35 USC 119 and 37 CFR 1.55(a), the applicant hereby claims the right of priority based on the following application(s):

Country

Application No.

Filed

REPUBLIC OF KOREA

P2000-41385

07/19/00

A certified copy of the above-noted application(s) is(are) attached hereto.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. 1.16 or under 37 C.F.R. 1.17; particularly, extension of time fees.

Respectfully submitted,

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/kw

June 5, 2001 BSKB, LLD (703) 205-8000 0465-0747D 10F1

대 한 민 국 특 허 청 KOREAN INDUSTRIAL PROPERTY OFFICE

별첨 사본은 아래 출원의 원본과 동일함을 증명함.

This is to certify that the following application annexed hereto is a true copy from the records of the Korean Industrial Property Office.

출 원 번 호 :

특허출원 2000년 제 41385 호

Application Number

출 원 년 월 일

2000년 07월 19일

Date of Application

출 원 인 :

현대전자산업주식회사

Applicant(s)



2000 08 17 년 월 일

투 허 청 COMMISSIONEI

